



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Reid et al.

Attorney Docket No.: NOVLP020

Application No.: 09/927,741

Examiner: Wesley A. Nicolas

Filed: August 10, 2001

Group: 1742

Title: Improved Clamshell Apparatus for  
Electrochemically Treating Wafers

5/a  
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TC 1700

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on August 14, 2003 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:

Natalie Morgan

Natalie Morgan

**AMENDMENT A**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated May 15, 2003 ("Office Action"), please amend the above-identified patent application as follows:

A **Listing of Claims** begins on page 2 of this paper.

A **Remarks/Arguments** section begins on page 7 of this paper.